Receipt date: 10/23/2008 10569796 - GAU: 2829

#### PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q91474

Hideyuki OHTAKE, et al.

Allowed: August 8, 2008

Appln. No.: 10/569,796

Group Art Unit: 2829

Confirmation No.: 6630

Examiner: Richard Isla RODAS

Filed: February 27, 2006

For:

ELECTRIC-FIELD DISTRIBUTION MEASUREMENT METHOD AND APPARATUS

FOR SEMICONDUCTOR DEVICE

# AMENDMENT UNDER 37 C.F.R. §1.312

### MAIL STOP ISSUE FEE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 C.F.R. §1.312, please amend the above-identified application as follows on the accompanying pages.

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OK TO ENTER: /RI/

/Richard Isla Rodas/ 11/12/2008